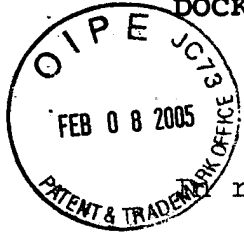


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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Patent Application of: Kwan-Yong LIM, et al.

Serial No.: 10/725,320

Group Art Unit: 2825

Filed: December 2, 2003

Examiner: Anya, Igwe U

For: METHOD FOR FABRICATING GATE-ELECTRODE OF SEMICONDUCTOR
DEVICE WITH USE OF HARD MASK

* * * * *

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 8, 2005

Sir:

Responsive to the Office Action mailed September 10, 2004,
kindly enter the following amendments and remarks.